Docket No.: 8733.428.00

the specification of which

Declaration, Power of Attorney and Petition

WE (I) the undersigned inventor(s), hereby declare(s) that:

My residence, post office address and citizenship are as stated below next to my name,

We (I) believe that we are (I am) the original, first, and joint (sole) inventor(s) of the subject matter which is claimed and for which a patent is sought on the invention entitled

METHOD OF FABRICATING A THIN FILM TRANSISTOR AND MANUFACTURING EQUIPMENT

	is attached l	nereto.					
	□ was filed or	ı					
		as Application Serial	No.				
		and amended on					
specif		te that we (I) have revie e claims, as amended by a				ne above-identif	ied
applic		ge the duty to disclose in Section 1.56 of Title 37 Co			to the p	patentability of t	his
desigi check	cation(s) for patent nated at least one co- ing the box, any for	im foreign priority benef- or inventor's certificate, ountry other than the Unit eign application for paten that of the application or	or §365(a) of any PC ted States, listed below at or inventor's certificat	T Internand have e, or PC	ational also io F Interr	application wh dentified below, national applicat	ich by ion
	Application No.	Country	Day/Month/Year	n	ority Cla	.i.u. a.d	
	- Processor		Day/Month/Tear	rn		imed	
	2000-26788	KOREA	18 May 2000		•	No	
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orovis	2000-26788	im the benefit under Tit	18 May 2000	-	es C	No No	utes

Status (pending, patented, abandoned)

Application Serial No.

of any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT International application in the manner provided by the first paragraph of 35 U.S.C. §112, I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR §1.56 which became available between the filling date of the prior application and the national or PCT International filling date of this application.

Filing Date

And we (I) hereby appoint Song K. Jung, Reg. No. Springer, Reg. No. 39,843; and Rebecca A. Goldm full powers of substitution and revocation, to prosecute	an, Reg. No.	41,786 and	l as our (my) attorneys, with		
Patent Office connected therewith; and we (I) hereby requ					
be sent to Song K. Jung of Long Aldridge & Norman l	LLP, Attorne	ys At Law,	6th Floor, 701 Pennsylvania		
Avenue, N.W., Washington, D.C. 20004.					
We (I) declare that all statements made herein	of our (my) own knov	wledge are true and that al		
statements made on information and belief are believed to					
with the knowledge that willful false statements and the					
or both, under Section 1001 of Title 18 of the United St			willful false statements may		
jeopardize the validity of the application or any patent iss	uing thereon.				
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Signature of Inventor	Post Office	Addmoon!	Same As Above		
t 0 2001	rost Office i	Address.	Same As Above		
5.7.2001					
Date Warren KIM	.	640/1204	S. L		
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